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BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 2896

| SERIAL NUMBER 09/767,659 | FILING OR 371(c) | CLASS 414 | GRO | GROUP ART UNIT 3652 | | ATTORNEY DOCKET NO. A-67736-1/MSS (463035-19) | |
|--|--|--------------|-----------------------------------|---|--|--|--|
| APPLICANTS Richard N. Savage, Scotts Valley, CA; Frank S. Menagh, Santa Cruz, CA; Helder R. Carvalheria, Scotts Valley, CA; Philip A. Troiani, Santa Cruz, CA; Dan L. Cossentine, Santa Cruz, CA; Eric R. Vaughan, Santa Cruz, CA; Bruce E. Mayer, Soquel, CA; | | | | | | | |
| ** CONTINUING DATA *************************** This application is a DIV of 09/483,945 01/13/2000 PAT 6,610,150 and claims benefit of 60/127,532 04/02/1999 and claims benefit of 60/127,650 04/02/1999 ** FOREIGN APPLICATIONS ************************************ | | | | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditio met Verified and Acknowledged Ex | state or country CA | DRA | SHEETS TOT DRAWING CLA 16 6 | | | INDEPENDENT CLAIMS 2 | |
| ADDRESS 32940 TITLE SEMICONDUCTOR WAFER PROCESSING SYSTEM WITH VERTICALLY-STACKED PROCESS CHAMBERS | | | | | | | |
| FILING FEE FEE RECEIVED No. | EES: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following: | | | All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit | | | |